



Moisture Analyzers

MM500

The absolute measurement for moisture in Process Gas Analysis.

The MM500 Moisture Analyzers represent the latest advance in moisture analysis – designed to be customised to your application giving precise measurements while providing a simple, yet affordable analyzer.

All instruments in the range incorporate microprocessor control, with our high quality electrolytic moisture sensor, to bring flexibility to your process environment.

These analyzers provide an absolute measurement, with accurate dependable results over a wide range from 0.01ppm to 1000ppm. Unit of measurement can be selected from ppmv or dew point (°C or °F).

The sample systems for all MM500 instruments are manufactured using stainless steel throughout.

Simply select the instrument configuration and sensor location and let the analyzer do the rest.

Cabinetry & Mounting

The MM500 can be configured in 3 different cabinets.

The sensor can be remote mounted from any of these configurations:

- Panel or bench mount
- NEMA 4X / IP66 waterproof and weatherproof
- 19" rack mount

Options

- Scalable Analog outputs
- High / Low Alarms
- Programmed Calibration Check
- Thermal Mass Flow Control
- Remote Mounted Sensors
- Fault Alarm

All Systech Illinois sensors are made to laboratory standards of precision and industrial standards of durability. Stainless steel housings, lab grade components and controlled environment manufacturing ensure the finest, most consistently precise sensors in the industry.

Versatile Configurations

Combine the MM530 with any of our oxygen or carbon dioxide analyzers to create a dual gas analyzer. Both units fit into a 19" rack mountable cabinet.



MM510



MM520



MM530

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Custom Configuration

The Thermal Mass Flow Controller option for the internal sensor model automatically maintains the correct flow for maximum accuracy. An added benefit with this option is flow alarms to ensure the instrument and sample system are always in the correct configuration.

A remote sensor is available in a wall mounted cabinet. The IP66/NEMA 4X cabinet includes the P₂O₅ sensor along with flow meter and control valve. Wall mounted brackets are provided for easy installation.

For increased peace of mind, an autocalibrate check option is available. The instrument can be connected to certified gas and programmed to perform a calibration check at regular intervals. The instrument displays a warning and fault alarm if the error exceeds preset limits.

Model	MMXX0	MMXX1	MMXX2
Sensor Configuration	Integral	Remote	Integral
Flow Controller	Differential Pressure	Differential Pressure	Mass Flow control
Materials of Constuction	stainless steel /platinum / ptfе	stainless steel /platinum / ptfе	stainless steel /platinum / ptfе
Application	General purpose	General purpose	General purpose

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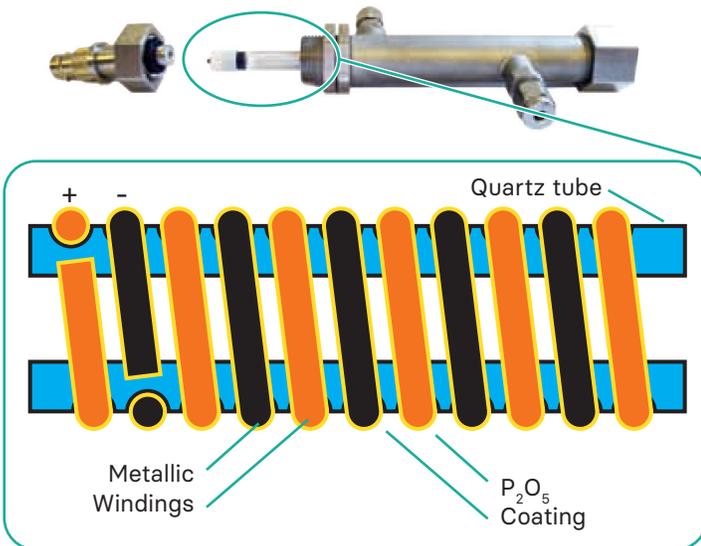
Principle of Operation

To achieve an absolute measure, the technology draws upon a fundamental principle of physics.

The phosphorus pentoxide (P_2O_5) moisture sensor consists of a dual platinum winding formed around a quartz tube about 8cm long.

The extremities of the windings are sealed by a resin coating, and the bare platinum electrodes coated with a thin film of P_2O_5 . PTFE guides are provided at each end of the sensor through which the electrical connections to the windings protrude. A constant voltage is applied across the windings and the resultant current is monitored. As a flow of gas is passed over the sensor, the moisture in the gas stream is attracted to the P_2O_5 coating, and the resistance of the platinum coil changes due to the electrolysis of the moisture into hydrogen and oxygen gases. This change in resistance creates a change in the measured current, that according to Faraday's Law is directly proportional to the amount of moisture in the gas stream.

Therefore, a knowledge of the gas flow rate through the sensor and the current in the cell gives an absolute measure of the moisture contained in the sample gas.



Features & Benefits

- Autoranging from 0.01 to 1000ppm
- RS232/485 outputs
- ppmv, Dew Point °F and °C units
- No calibration required
- Remote sensors available
- Fault alarm

Applications

- Industrial Specialty Gases
- Heat Treating Furnaces
- Air Dryers
- Plastics Manufacturing
- Chemical Manufacturing
- Metallurgy
- Compressed Air
- Inert Atmosphere Blanketing



Remote sensor assembly (IP66/NEMA 4X)

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Technical Specification

Measurement Ranges	Autoranging from 0.01ppm to 1000ppm and equivalent in Dew Point
Accuracy	±5% of reading or 0.4 ppm(v)
Response Time	90% within 60 seconds
Selectable Units	ppm(v) / Dew Point °C / Dew Point °F
Display Type	5 digit high visibility LED
Operating Conditions	Sample and ambient temperature: 32–104°F (0–40°C)
Sample Connections	1/8in. Swagelock® type, stainless steel
Maximum Sample Pressure	0.25 – 7.0 Barg
Sample Flow	100 cc/min -controlled
Power Requirements	115/230VAC, 50/60Hz, selectable. 12VA
Acceptable Gases	All inert gases, N ₂ , H ₂ , O ₂ , CO ₂

Options

Analog Outputs	Scaleable 0 - 10V, 0 - 100mV and 4 - 20mA or 0 - 20mA all isolated
High / Low Alarms	2 voltage free with changeover contacts rated 240V 3A
19" Rack Mount	Can be combined with many of our other products in a 19" rack mount configuration
Remote Mounted Sensors	General purpose sensors can be remote mounted up to 328.08 ft away
Flow Control	Thermal mass flow control, pressure regulators, bypass flow system

Weights & Dimensions

	Weight (lb)	Width (in)	Depth (in)	Height (in)
MM510 Bench/Panel Mount	17.41	9.33	16.14	7.48
MM520 IP66/NEMA 4X	28.8	14.96	6.3	18.11
MM530 (single unit) Rack Mount 4U - 19 inch Houses 1 or 2 analyzers	21.3	19	16.14	7

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